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APR - 9 2007

In re Application of Takafuji et al.	:	
Application Number : 10/668,186	:	DECISION ON
Filed: September 24, 2003	:	PETITION TO
Attorney Docket Number: 1248-0673P	:	WITHDRAW
For: Single-Crystal Silicon Substrate, SOI Substrate,	:	FINALITY
Semiconductor Device, Display Device, And		
Manufacturing Method of Semiconductor Device		

This decision is in response to petitioner's "PETITION UNDER 37 C.F.R. § 1.181 WITHDRAWAL OF FINALITY OF OUTSTANDING OFFICE ACTION" filed 5 December 2006, to invoke the supervisory authority of the Director of the USPTO to review the action of the examiner in the above-identified application. The petition is before the Director of Technology Center 2800 for review.

The petition is **GRANTED** to the extent indicated below.

The final rejection mailed 5 December 2006 introduced a new ground of rejection that was not necessitated by the petitioner's amendment filed 8 May 2006. Claim 22 was originally indicated as being allowable over the cited art of record in the office action mailed 7 February 2006. A new ground of rejection was made in the final rejection mailed 5 October 2006 and the allowability of claim 22 was withdrawn. Claim 22 was not amended by the petitioner and therefore did not necessitate the new grounds of rejection. The finality will be withdrawn, the Office will send out a non-final office action and the shorten statutory period will be restarted.

Sharon A. Gibson, Director
Technology Center 2800 – Semiconductors, Electrical and
Optical Systems and Components